

**Amendments to the Specification**

Please amend the specification as follows: On page 8, please replace the paragraph that starts on line 16 with the word "Other" and ends on line 20 with the word "(1997)." with the following amended paragraph:

Other rotating micro-mirror designs are disclosed in [[a]] commonly assigned U.S. Patent ~~application~~ No. 6,483,957 (Hamerly et al.) ~~entitled "MEMS Based Polarization Mode Dispersion Compensator", filed \_\_\_\_\_, (Attorney docket no. 56130USA3A)~~ and Butler et al., Scanning and Rotating Micromirrors Using Thermal Actuators", 3131 SPIE 134-144 (1997).

On page 9, please replace the paragraph that starts on line 1 with the word "Various" and ends on line 5 with the words "serial no. 09/659,798." with the following amended paragraph:

Various thermal actuator structures can be used in the present invention, such as disclosed in commonly assigned U.S. Patent Application Publication No. applications 2002/0195674 A1 (Weaver et al.) ~~entitled "Direct Acting Vertical Thermal Actuator", filed September 12, 2000, serial no. 09/659,572~~ and U.S. Patent No. 6,531,947 (Weaver et al.) ~~"Direct Acting Vertical Thermal Actuator with Controlled Bending", filed September 12, 2000, serial no. 09/659,798.~~